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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 9577

Tetsuji TOGAWA et al.

Docket No. 2001-0998A

Serial No. 09/903,581

Group Art Unit 3723

Filed July 13, 2001

Examiner Eileen P. Morgan

POLISHING APPARATUS

AMENDMENT

RECEIVED

APR 19 2004

TECHNOLOGY CENTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of January 14, 2004, kindly amend the above-referenced U.S. patent application as follows: